



TSMC-00-096

2825 #2
BT
01-25-02

October 26, 2001

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

Subject:

Serial No. 09/942,289 08/30/01

Chien-Chung Huang, Hsiao-Lung Chu,
Yu-Feng HuangOPERATION-SUPERVISION INTEGRATED
INTERFACE

Grp. Art Unit: 2825

RECEIVED
DEC 11 2001
PTO MAIL ROOM

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56. Copies of each document is included herewith.

U.S. Patent 5,778,386 to Lin et al., "Global View Storage
Management System for Semiconductor Manufacturing Plants,"
discloses global view management system for semiconductor
plants.

TSMC-00-096

U.S. Patent 5,960,417 to Pan et al., "IC Manufacturing Costing Control System and Process," discloses an IC manufacturing control system.

U.S. Patent 5,999,920 to Sato et al., "System for Assisting in Management of Packaging Plant," discusses a system for management of a plant.

U.S. Patent 5,239,487 to Horejsi et al., "Computer Integrated Manufacturing Rework Apparatus and Method," discloses a CIM rework method.

Sincerely,



Stephen B. Ackerman,
Reg. No. 37761